

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named
Inventor : Benjamin Y.H. Liu et al.

Conf. No. 7978

Appln. No. : 10/769,011

Filed : January 30, 2004

Group Art Unit: 1763

For : HIGH-PERFORMANCE AND MULTI-
LIQUID-PRECURSOR
VAPORIZATION IN
SEMICONDUCTOR THIN FILM
DEPOSITION

Examiner: R. Bueker

Docket No.: M419.12-0043

**RESUBMITTED AMENDMENT IN RESPONSE TO NOTICE OF NON-
COMPLIANT AMENDMENT**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

**VIA ELECTRONIC FILING
APRIL 29, 2008**

In response to the Notice of Non-Compliant Amendment dated April 14, 2008 and further in response to the Official Action Mailed September 7, 2007, it is respectfully requested that the following amendments be made.